10/033644 12/27/01

PATENT NUMBER and ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER
10033644	12/27/2001	438		2812	T. Nguyen

**APPLICANTS: Mikhaylichenko Katrina; Ravkin Michael; deLarios John;

**CONTINUING DATA VERIFIED:

** FOREIGN APPLICATIONS VERIFIED:

PG-PUB	DO NOT PUBLISH ☒	RESCIND ☐	
Foreign priority claimed	☐ yes ☐ no	ATTORNEY DOCKET NO	
35 USC 119 conditions met	☐ yes ☐ no	LAM2P316	
Verified and Acknowledged Examiners's intials			

TITLE : Method for post-etch and strip residue removal on coral films

U.S.DEPT. OF COMM./PAT.& TM-PTO-436L(Rev 12-94)

NOTICE OF ALLOWANCE MAILED	Assistant Examiner	CLAIMS ALLOWED: Total Claims / Print Claim for O.G
ISSUE FEE: Amount Due / Date Paid	Primary Examiner	DRAWING: Sheets Drwg. / Figs.Drwg. / Print Fig.
☐ TERMINAL DISCLAMER	PREPARED FOR ISSUE	Application Examiner

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